



501.36931CX2

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): T. Iwasaki, et al.

Appln. No. 09/255,856

Filed: February 23, 1999

For: SEMICONDUCTOR DEVICE WITH LAYERED INTERCONNECT
STRUCTURE

Group: 2813

Examiner: S. Smoot

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AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

January 29, 2004

Sir:

In response to the Office Action mailed July 29, 2003, please amend the
above-identified application as listed below and as set forth on the following pages:

Amendments to the Claims; and

Remarks are included following the amendments.